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Attorney's Docket No.: 05542-527001 / 008218/CMP

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Applicant : Dan A. Marohl et al. Art Unit : Unknown
Serial No. : 10/659,047 Examiner : Unknown
Filed : September 8, 2003
Title : RETAINING RING WITH FLANGE FOR CHEMICAL MECHANICAL POLISHING

Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

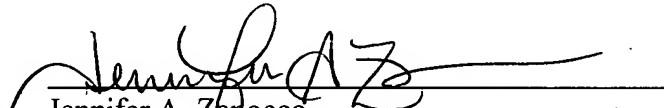
INFORMATION DISCLOSURE STATEMENT

Applicant submits the references listed on the attached form PTO-1449.

This statement is being filed within three months of the filing date of the application or before the receipt of a first Office action on the merits. Please apply any charges or credits to Deposit Account No. 06-1050.

Respectfully submitted,

Date: Nov 18, 2003



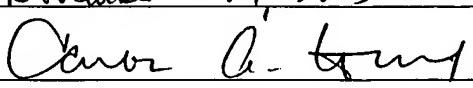
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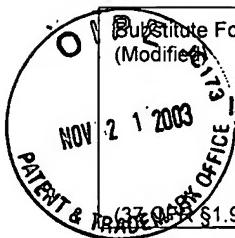
CERTIFICATE OF MAILING BY FIRST CLASS MAIL

I hereby certify under 37 CFR §1.8(a) that this correspondence is being deposited with the United States Postal Service as first class mail with sufficient postage on the date indicated below and is addressed to the Commissioner for Patents, P.O. Box 1450, Alexandria, VA 22313-1450.

November 19, 2003
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Substitute Form PTO-1449
(Modified)U.S. Department of Commerce
Patent and Trademark OfficeAttorney's Docket No.
05542-527001Application No.
10/659,047
Information Disclosure Statement
by Applicant
(Use several sheets if necessary)
Applicant
Dan A. Marohl et al.Filing Date
September 8, 2003Group Art Unit
Unknown**U.S. Patent Documents**

Examiner Initial	Desig. ID	Document Number	Publication Date	Patentee	Class	Subclass	Filing Date If Appropriate
	AA	5,205,082	04/27/93	Shendon et al.			
	AB	5,423,558	06/13/95	Koeth et al.			
	AC	5,584,751	12/17/96	Kobayashi et al.			
	AD	5,605,488	07/25/97	Ohashi et al.			
	AE	5,635,083	06/03/97	Breivogel et al.			
	AF	5,643,053	07/01/97	Shendon			
	AG	5,643,061	07/01/97	Jackson et al.			
	AH	5,645,474	07/08/97	Kubo et al.			
	AI	5,647,789	07/15/97	Kitta et al.			
	AJ	5,695,392	12/09/97	Kim			
	AK	5,759,918	06/02/98	Hoshizaki et al.			
	AL	5,851,140	12/22/98	Barns et al.			
	AM	6,277,008	08/21/01	Masuta et al.			

Foreign Patent Documents or Published Foreign Patent Applications

Examiner Initial	Desig. ID	Document Number	Publication Date	Country or Patent Office	Class	Subclass	Translation
							Yes No
	AN	EP 0 747 167 A2	12/96	EPO			
	AO	EP 0 776 730 A1	06/97	EPO			
	AP	EP 0 790 100 A1	08/97	EPO			
	AQ	EP 0 841 123 A1	05/98	EPO			
	AR	EP 0 988 931 A2	03/00	EPO			
	AS	GB 2 307 342 A	05/97	GB			
	AT	GB 2 336 121 A	10/99	GB			

Examiner Signature	Date Considered
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Substitute Form PTO-1449 (Modified)		U.S. Department of Commerce Patent and Trademark Office	Attorney's Docket No. 05542-527001	Application No. 10/659,047
Information Disclosure Statement by Applicant (Use several sheets if necessary)		Applicant Dan A. Marohl et al.		
		Filing Date September 8, 2003	Group Art Unit Unknown	
(37 CFR §1.98(b))				

Other Documents (include Author, Title, Date, and Place of Publication)		
Examiner Initial	Desig. ID	Document
	AU	"High-Tech Resins Boost Chip Production", Machine Design, November 7, 1996, pp 52+. ["Machine Design"]
	AV	"Advanced Engineering Plastics for the Semiconductor Industry", DSM Engineering (Polymer Corporation), 1996. ["DSM"]
	AW	"Advanced Engineering Plastics for the Semiconductor Industry", DSM Engineering (Polymer Corporation), 1997. ["DSM"]

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